



DOCUMENT CHANGE REQUEST

DCR number 647

Changes required for: N/A

Originator: John Wong

Date: 2011/03/18

Date sent: 2011/02/04

Organisation: ESA/ESTEC

Status: IMPLEMENTED

Title: ESCC Qualified Manufacturers List REP006

Number: REP006

Issue: 4

Other documents affected:

Page:

1. Technology Flow
5.1

Paragraph:

1. Technology Flow
5.1

Original wording:

Proposed wording:


1. Wafer Fab is changed from Atmel Rousset to Lfoundry, Rousset

5.1 Under "Maintenance of Qualification" add:

- Qualification Certificate No.: 278B
- Validity Date: December 2010 to December 2011

Justification:

Extension of qualification through CNES application 274B.

Attachments:
N/A
Modifications:
N/A
Approval signature:

Date signed:
2011-03-18